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FOR THE COMMANDER

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FOREWORD

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5470	Circular Harmonic Analysis of PSFs Corresponding to Separable Polar-Coordinate Frequency Responses with Emphasis on Fan Filtering	Verly, J.G. Peli, T.	IEEE Trans. Acoust. Speech Signal Process., Vol. ASSP-33, No. 1, February 1985, pp. 300-307 ADA160438
5486	InP Optoelectronic Switches	Foyt, A.G. Leonberger, F.J.	Chapter 9, *Picosecond Optoelectronic Devices,* Academic Press, NY, 1984, pp. 271-311
5506	Direction Determination of Wideband Signals	Lacoss, R.T. Dowla, F.U. Hamid, N.S.	IEEE Trans. Acoust. Speech Signal Process., Vol. ASSP-33, No. 4, October 1985, pp. 1114-1122
5518	Zone-Melting Recrystallization of Si Films on SiO_2	Tsaur, B-Y.	Chapter 2, *Silicon-on-Insulator: Its Technology and Applications,* KTK Scientific Pub., Tokyo, 1985, pp. 101-128 ADA158743
5566	GaAlAs Semiconductor Diode Laser 4-ary Frequency Shift Key Modulation at 100 Mbit/s	Welford, D. Alexander, S.B.	Electron Lett., Vol. 21, No. 1, 3 January 1985, pp. 12-13 ADA151587
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5596	Laser-Induced Chemistry for Microelectronics	Osgood, R.M. Deutsch, T.F.	Science, Vol. 227, No. 4688, 15 February 1985, pp. 709-714
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5610	Submicrometer Patterning by Projected Excimer-Laser-Beam Induced Chemistry	Ehrlich, D.J. Tsao, J.Y. Bozler, C.O.	J. Vac. Sci. Technol. B, Vol. 3, No. 1, January/ February 1985, pp. 1-8 ADA151483
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5660	Masked Ion Beam Resist Exposure Using Grid Support Stencil Masks	Randall, J.N. Flanders, D.C. Economou, N.P. Donnelly, J.P. Bromley, E.I.	J. Vac. Sci. Technol. B, Vol. 3, No. 1, January/ February 1985, pp. 58-61 ADA151586
5661	Repair of X-Ray Lithography Masks Using UV-Laser Photodeposition	Randall, J.N. Ehrlich, D.J. Tsao, J.Y.	J. Vac. Sci. Technol. B, Vol. 3, No. 1, January/ February 1985, pp. 262-264 ADA151522
5662	Frequency Tuning Characteristics of a Q-Switched Co:MgF_2 Laser	Lovold, S. Moulton, P.F. Killinger, D.K. Menyuk, N.	IEEE J. Quantum Electron., Vol. QE-21, No. 3, March 1985, pp. 202-208
5664	Ion-Beam-Assisted Etching of Diamond	Efremow, N.N. Geis, M.W. Flanders, D.C. Lincoln, G.A. Economou, N.P.	J. Vac. Sci. Technol. B, Vol. 3, No. 1, January/ February 1985, pp. 416-418 ADA151426
5665	Error Reduction in Laser Remote Sensing: Combined Effects of Cross Correlation and Signal Averaging	Menyuk, N. Killinger, D.K. Menyuk, C.R.	Appl. Opt., Vol. 24, No. 1, 1 January 1985, pp. 118-131 ADA153153
5666	Effects of Ion Species and Adsorbed Gas on Dry Etching Induced Damage in GaAs	Pang, S.W. Geis, M.W. Efremow, N.N. Lincoln, G.A.	J. Vac. Sci. Technol. B, Vol. 3, No. 1, January/ February 1985, pp. 398-401 ADA151585
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5671	Selective Tungsten Silicide Formation by Ion-Beam Mixing and Rapid Thermal Annealing	Tsaur, B-Y. Chen, C.K. Anderson, C.H., Jr. Kwong, D.L.	J. Appl. Phys., Vol. 57, No. 6, 15 March 1985, pp. 1890-1894 ADA153728
5672	Single-Mode Optical Waveguides and Phase Modulators in the InP Material System	Donnelly, J.P. DeMeo, N.L. Leonberger, F.J. Groves, S.H. Vohl, P. O'Donnell, F.J.	IEEE J. Quantum Electron., Vol. QE-21, No. 8, August 1985, pp. 1147-1151
5674	Superconductive Chirp-Transform Spectrum Analyzer	Withers, R.S. Reible, S.A.	IEEE Electron Device Lett., Vol. EDL-6, No. 6, June 1985, pp. 261-263
5680	UV Laser Photodeposition of Patterned Catalyst Films from Adsorbate Mixtures	Ehrlich, D.J. Tsao, J.Y.	Appl. Phys. Lett., Vol. 46, No. 2, 15 January 1985, pp. 198-200 ADA151435
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5684	High-Field Electron Capture and Emission in Nitrided Oxides	Terry, F.L. Wyatt, P.W. Naiman, M.L. Mathur, B.P. Kirk, C.T. Senturia, S.D.	J. Appl. Phys., Vol. 57, No. 6, 15 March 1985, pp. 2036-2039 ADA153725
5686	On Combined Source Solutions for Bodies with Impedance Boundary Conditions	Rogers, J.R.	IEEE Trans. Antennas Propag., Vol. AP-33, No. 4, April 1985, pp. 462-465
5687	High Resistivity InGaAs(Fe) Grown by a Liquid Phase Epitaxial Substrate-Transfer Technique	Groves, S.H. Diadiuk, V. Plonko, M.C. Hovey, D.L.	Appl. Phys. Lett., Vol. 46, No. 1, 1 January 1985, pp. 78-80 ADA150697

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5689	Instruments and Methods for Microfabrication by Laser-Controlled Chemistry	Ehrlich, D.J.	Nucl. Instrum. Methods Phys. Res. A, Vol. A239, No. 3, 15 September 1985, pp. 397-402 ADA160827
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5696	Surface-Emitting GaInAsP/InP Laser with Low Threshold Current and High Efficiency	Liau, Z.L. Walpole, J.N.	Appl. Phys. Lett., Vol. 46, No. 2, 15 January 1985, pp. 115-117 ADA151425
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5707	Magnitude and Phase Characteristics of Frequency Modulation in Directly Modulated GaAlAs Semiconductor Diode Lasers	Welford, D. Alexander, S.B.	IEEE J. Lightwave Technol., Vol. LT-3, No. 5, October 1985, pp. 1092-1099
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5709	Multigigahertz Lumped-Element Electrooptic Modulators	Becker, R.A.	IEEE J. Quantum Electron., Vol. QE-21, No. 8, August 1985, pp. 1144-1146
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5943	Progress in Laser Sources for Remote Sensing	Menyuk, N. Mooradian, A. Moulton, P.F.	Workshop on Optical and Laser Remote Sensing, Monterey, CA, 9-11 February 1982, pp. H3-1 — H3-9
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6498	Low Altitude, One Centimeter, Space Debris Search at Lincoln Laboratory's (M.I.T.) Experimental Test System	Taff, L.G. Beatty, D.E. Yakutis, A.J. Randall, P.M.S.	Adv. Space Res., Vol. 5, No. 2, 1985, pp. 34-45

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6502	A Wafer-Scale Digital Integrator	Chapman, G.H. Konkle, K.H. Mathur, B.P. Soares, A.M. Raffel, J.I. Anderson, A.H. Wyatt, P.W.	IEEE ICCD '84, Intl. Conf. on Computer Design, 8-11 October 1984, pp. 121-126 ADA152771
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UNCLASSIFIED

SECURITY CLASSIFICATION OF THIS PAGE *(When Data Entered)*

REPORT DOCUMENTATION PAGE		READ INSTRUCTIONS BEFORE COMPLETING FORM
1. REPORT NUMBER ESD-TR-85-320	2. GOVT ACCESSION NO. AD-A167987	3. RECIPIENT'S CATALOG NUMBER
4. TITLE *(and Subtitle)* Unclassified Publications of Lincoln Laboratory — Volume 11		5. TYPE OF REPORT & PERIOD COVERED Bibliography, 31 December 1984 to 31 December 1985 6. PERFORMING ORG. REPORT NUMBER
7. AUTHOR*(s)* Publications Office		8. CONTRACT OR GRANT NUMBER*(s)* F19628-85-C-0002
9. PERFORMING ORGANIZATION NAME AND ADDRESS Lincoln Laboratory, M.I.T. P.O. Box 73 Lexington, MA 02173-0073		10. PROGRAM ELEMENT, PROJECT, TASK AREA & WORK UNIT NUMBERS None
11. CONTROLLING OFFICE NAME AND ADDRESS Air Force Systems Command, USAF Andrews AFB Washington, DC 20334		12. REPORT DATE 31 December 1985 13. NUMBER OF PAGES 68
14. MONITORING AGENCY NAME & ADDRESS *(if different from Controlling Office)* Electronic Systems Division Hanscom AFB, MA 01731		15. SECURITY CLASS. *(of this Report)* Unclassified 15a. DECLASSIFICATION DOWNGRADING SCHEDULE

16. DISTRIBUTION STATEMENT *(of this Report)*

Approved for public release; distribution unlimited.

17. DISTRIBUTION STATEMENT *(of the abstract entered in Block 20, if different from Report)*

18. SUPPLEMENTARY NOTES

None

19. KEY WORDS *(Continue on reverse side if necessary and identify by block number)*

Bibliography

20. ABSTRACT *(Continue on reverse side if necessary and identify by block number)*

Volume 11 of Unclassified Publications of Lincoln Laboratory lists reports published from 31 December 1984 to 31 December 1985, as well as updated information on earlier publications.

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DD FORM 1 Jan 73 1473 EDITION OF 1 NOV 65 IS OBSOLETE

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SECURITY CLASSIFICATION OF THIS PAGE *(When Data Entered)*

☆ U. S. GOVERNMENT PRINTING OFFICE: 1986--600-000--20,023